



FTW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chiaki SASAOKA
Title: SEMICONDUCTOR LASER
AND METHOD OF
FABRICATING THE SAME
Appl. No.: 10/549,447
International Filing Date: 2/26/2004
371(c) Date: 9/14/2005
Examiner: Yuanda Zhang
Art Unit: 2828
Confirmation Number: 5540

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated July 3, 2007, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: